

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: RUDOLF PETER MUIS ET AL. Serial No.: 10/514,424 Filed: MAY 26, 2005 For: METHOD AND APPARATUS FOR APPLYING A LAYER OF A SECOND MATERIAL TO A LAYER OF A NANOCRYSTALLINE FIRST MATERIAL	Art Unit: 4172 Examiner: ROLLAND, ALEX A.
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RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed on April 29, 2008, Applicants hereby provisionally elect, with traverse, to prosecute the claims of Group II (claims 2-11), but respectfully request withdrawal of the restriction requirement for the reasons set forth below. Please also amend the above-identified application as set forth below.

No extension of time or other fees are believed to be due, except as detailed in the attached documents. However, any extension of time necessary to prevent abandonment is hereby requested, and any fee necessary for consideration of this response is hereby authorized to be charged to Deposit Account Number 50-2613.

Amendments to the Claims: reflected in the list that begins on page 2 of this paper.

Remarks: begin on page 5 of this paper.